



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: KOCH et al.

Attorney Docket No.: KLA1P050

Application No.: 10/052,307

Examiner: UNASSIGNED

Filed: January 17, 2002

Group: 2881

Title: SCANNING ELECTRON MICROSCOPE
ARCHITECTURE AND RELATED MATERIAL
HANDLING SYSTEM

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on August 21, 2002.

Signed: 

Sandra Halliwell

INFORMATION DISCLOSURE STATEMENT
37 CFR §§ 1.56 AND 1.97(b)

Commissioner for Patents
Washington, DC 20231

Dear Sir:

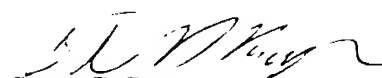
The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. KLA1P050).

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP


Steve D Beyer
Registration No. 31,234

P.O. Box 778
Berkeley, CA 94704-0778
(650) 961-8300

